

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of :
Takayuki ABE et al. : **Confirmation No. 3555**
Serial No. 10/540,487 : **Mail Stop: MISSING PARTS**
Filed June 23, 2005 : **Attorney Docket No. 2005_1034A**

POLYGONAL BARREL SPUTTERING
DEVICE, POLYGONAL BARREL
SPUTTERING METHOD, COATED FINE
PARTICLE FORMED BY THE DEVICE AND
METHOD, MICRO CAPSULE, AND METHOD
OF PRODUCING THE MICRO CAPSULE
[Corresponding to PCT/JP2003/016244
Filed June 23, 2005]

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT


Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In supplement to the Information Disclosure Statement filed June 23, 2005, submitted herewith are a Notification of Reasons for Refusal issued by the Japanese Patent Office in a counterpart application, and an English translation thereof.

Respectfully submitted,

Takayuki ABE et al.

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